



Attorney Docket No. 0756-7289

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	Group Art Unit:
Shunpei YAMAZAKI et al.	)	Examiner:
Serial No. 10/820,781	)	<u>CERTIFICATE OF MAILING</u>
Filed: April 9, 2004	)	I hereby certify that this correspondence is
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SEMICONDUCTOR DEVICE	)	Commissioner for Patents, P.O. Box 1450,
	)	Alexandria, VA 22313-1450, on
	)	<u>8-19-04</u>
	)	<u>Adile M. Stampu</u>

**PRELIMINARY AMENDMENT**

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper.

**Remarks** begin on page 14 of this paper.